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Docket No.: S1432-700819

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE


Applicant: Yeshwanth Narendar et al.  
Serial No: 10/752,434  
Confirmation No: 3742  
Filed: January 6, 2004  
For: HIGH PURITY SILICON CARBIDE ARTICLES AND METHODS

Examiner: Karl E. Group  
Art Unit: 1755

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Stephanie Godino

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE

Sir:

In response to the Office Action mailed January 20, 2006, please amend the above-identified application as follows. Changes to the Claims are shown by strike through (for deleted matter) and underlining (for added matter).

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.